

Internship

Vanadium Dioxide-Based Films for Randomizing Photonic Emission and Absorption of Integrated Circuits

Period:	March to August 2024
Location:	Laboratoire Hubert Curien, Université Jean Monnet (Saint-Étienne, France)

Project:

The goal is to develop a smart coating that will prevent exploiting the photonic emission and absorption from integrated circuits, effectively limiting the use of optical techniques to reverse-engineer microchips or access the stored secret data.

The semi-conductor material of transistors in an electronic circuit emits and absorbs nearinfrared radiation that can be used to obtain (passive attack) or change (active attack) the state of the circuit and access stored data or its exact configuration. A thermochromic coating based on vanadium dioxide (VO₂) will be developed to alter the photonic properties of the chip owing to heat variations during the attack. VO₂ is a well-known thermochromic material turning from a transparent dielectric to an opaque metal when heated above 68° C. VO₂ films can be easily synthesized using pulsed-laser deposition and thermal annealing, and will be used as a very thin and hard-to-detect coating on electronic chips. Its critical temperature can be adapted to any range of circuit operating temperature by varying the synthesis parameters, doping, post-treatment or inducing strain.

Tailoring VO_2 optical and thermal properties will lead to new applications not only in cybersecurity - the main focus of the project - but also in the domains of smart windows, infrared imaging, thermo-switchable optical, IR and RF devices, etc.

Environment:

This internship is part of the ANR Project "VO2Random", done in collaboration with the Institut Jean Lamour (Nancy).

The intern will be part of both the Laser-Matter Interaction team (LMT) and the Secure Embedded Systems & Hardware Architectures team (SESAM) at the Laboratoire Hubert Curien. She/He will have access to all the systems allowing for the synthesis and characterization of vanadium-based materials: femtosecond lasers and vacuum chambers for pulsed-laser deposition, Rapid Thermal Annealing ovens, Scanning and Transmission electron microscopy (SEM, TEM) coupled with Energy Dispersive Spectroscopy (EDX), Atomic Force Microscopy (AFM), Raman microscopy, ellipsometry and so on. She/He can expect to be formally trained and acquire experience on most of these devices.

Requirements:

The ideal candidate should have a strong background in physics, and be in her/his second year of a master's program (or equivalent degree) specializing in photonics and/or material science. Experience with electronics and knowledge in cybersecurity is not mandatory but will be appreciated.

She/He should have good organization skills and be able to manage the synthesis and characterization of numerous samples using many different techniques. A solid scientific culture and ability to communicate and "popularize" scientific results will be essential to ensure interaction between two teams working on distinct subjects.

Prospects:

Funding for a 3-years PhD has been obtained through the VO2Random ANR project. **Should** the appointed intern decide to apply, she/he will have increased chances to be selected for this PhD position.

How to apply:

Interested applicants are invited to send their CV before 15/12/2023, to: Florent Bourquard, Associate Professor: florent.bourquard@univ-st-etienne.fr Lilian Bossuet, Professor: lilian.bossuet@univ-st-etienne.fr